## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.

: National Phase Entry of PCT/JP2004/014093

Applicant

: Kazuyoshi OKAMOTO

Filed

: Herewith

TC/A.U.

Examiner

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Docket No.

: 3306-106

Customer No.: 6449

Confirmation No.:

## **INFORMATION DISCLOSURE STATEMENT**

Director of the United States Patent and Trademark Office P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

In compliance with applicants duty of disclosure under 37 C.F.R. 1.56, enclosed is a copy of the International Search Report in the corresponding international application. The relevance of the references 1-6 are noted in the International Search Report and copies of the references are provided herewith for Examiner's review. Reference 7 is cited in the current specification.

Please charge any fee deficiency or credit any overpayment to Deposit Account No. 02-2135.

Respectfully submitted,

Bv

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Application Number	New Application			
				Filing Date	Herewith			
			N I	First Named Inventor	Kazuyoshi OKAMOTO			
				Group Art Unit				
				Examiner Name				
				Confirmation No.				
Sheet	1	of	1	Attorney Docket Number	3306-106			

FOREIGN PATENT DOCUMENTS											
Examiner Initials*	Cite No.1	Office <sup>3</sup> Code	Foreign Patent Docur	nent Kind <sup>5</sup> (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T <sup>6</sup>				
	1.	wo	01/55491	A1	Shima Seiki Mfg., Ltd.	8/2/01					
	2.	wo	01/55492	A1	Shima Seiki Mfg., Ltd.	8/2/01					
	3.	EP	1 264 922	A1	Shima Seiki Mfg., Ltd.	12/11/02					
	4.	JP	2-229248		Shima Seiki Mfg., Ltd.	9/12/90					
	5.	GB	2 228 750	А	Shima Seiki Mfg., Ltd.	9/5/90					
	6.	JP	57-199844		Shima Idea Center KK	12/7/82					
	7.	JP	4-15301		Shima Seiki Seisakusho:KK	9/12/90	АВ				
		<u> </u>									
Examiner Signature					Date Considered						

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code. ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language translation is attached. AB indicates that only an English language abstract is attached.